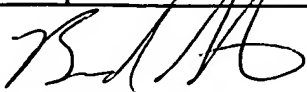


INFORMATION DISCLOSURE STATEMENT			Atty Docket: Serial No.: Applicant: Filing Date: Group:		02GR102454481 Not Yet Assigned Gris Herewith		
U.S. PATENT DOCUMENTS							
Examiner Initials		Document Number	Date	Name	Class	Sub Class	Filing Date
BKS	AA	6,358,809	3/19/02	Nobinger et al.	438	382	
	AB						
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	AK						
	AL						
	AM						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub Class	Translation
BKS	AN	0167851	1/15/86	EP	H01L21	66	
	AO						
	AP						
	AQ						
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
BKS	AR	Patent Abstracts of Japan, Vol. 017, No. 475 (C-1103), August 30, 1993 & JP 05117088A (Sumitomo Electric Ind. Ltd.), May 14, 1993					
	AS	Hutchings, Localized Semiconductor Diffusions Utilizing Local Laser Melting in Doping Atmospheres, January 1974, IBM Technical Disclosure Bulletin, Vol. 16, No. 8, January 1, 1974, Pages 2585-2586, XP002246185					
	AT						
EXAMINER: 				DATE CONSIDERED: 2/20/05			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.